### Continuous Emissions Monitoring and Process Control





# **Fertilizer Production**

## Continuous Emissions Monitoring and Process Control in Fertilizer Production

The use of gas monitoring systems in stacks and gas ducts is very important in the chemical industry, both in order to increase plant efficiency and to control emissions. However, the nature of chemical manufacturing processes places severe limitations on the monitoring methods that can be used. Aggressive environments combined with high levels of particulates and gases make the choice extremely limited.

#### The Opsis System

Opsis emissions monitoring systems are designed for environments such as those in the fertilizer industry. They are meeting a diverse range of chemical industry demands for reliability and performance on many sites around the world. Using DOAS (Differential Optical Absorption Spectroscopy) an Opsis system provides an open path, non-contact monitoring system unaffected by the gases, temperatures and particulates typical of chemical manufacturing processes. Being able to monitor a range of user-specified compounds continuously in real time with a single system, the Opsis instruments offer high levels of accuracy, reliability and data capture. They also offer the speed of response needed for process control.

A single Opsis system will monitor several compounds. As well as monitoring common gases such as nitric oxide (NO), nitrogen dioxide (NO<sub>2</sub>), sulphur dioxide (SO<sub>2</sub>), carbon dioxide (CO<sub>2</sub>) and water (H<sub>2</sub>O), Opsis can monitor ammonia (NH<sub>3</sub>) in fertilizer plants.

In addition, Opsis offers dilution extractive and heated extractive systems.

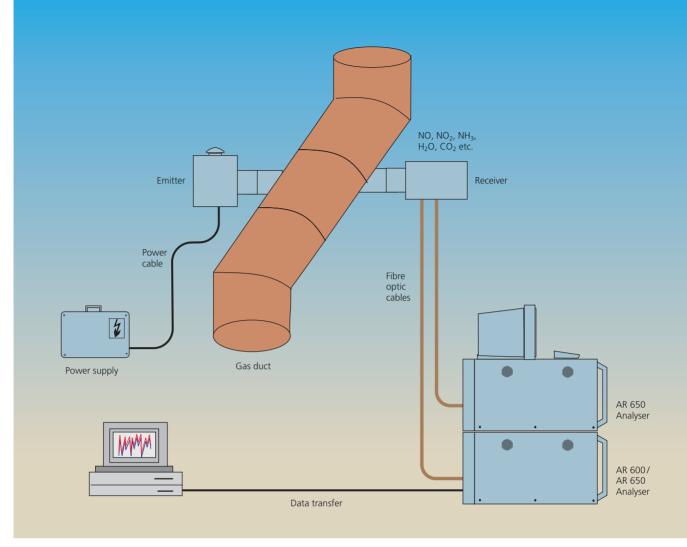
#### The Opsis Technique

An Opsis system includes one or several light paths crossing the stacks or ducts. In each path, light is projected from an emitter to a receiver. It is then transmitted to the Opsis analyser via a fibre optic cable. Using Beer Lambert's Law, the analyser then detects and measures compounds specified in the system software and logs data to a hard disk, either in a local or remote PC. This computer may act as a real-time display or, when required, run an analytical or statistical software generating any desired report.

The Opsis analyser will also accept continuous data from sensors monitoring process variables such as temperature, pressure and flow (4 to 20 mA or digital input). This, combined with the system's ability to provide alarm outputs and/or interface with process control systems via serial communication, makes Opsis to play a fully integrated part of automatic plant management. Integrating sensor and light path data in Opsis software also allows the automatic calculation and generation of reports meeting legislative requirements.

#### Tests and Approvals

Opsis has been tested and approved by a number of internationally recognized institutes and authorities. The system meets the U.S. EPA requirements, 40 CFR Parts 60 and 75, with the ER 070 and ER 080 units. Furthermore, it meets the German TÜV requirements, with the ER 060. Full details are available on request.



An Opsis system layout for a fertilizer plant

#### Performance Data (additional compounds can be monitored)

Compound	Max. measurement range (1 m path) <sup>(1)</sup>	Lowest TÜV approved measurement range	Min. detectable quantities (monitoring path 1 m, measurement time 30 sec.)	Zero drift (1 m path, max. per month) <sup>(5)</sup>	<b>Span drift</b> (per month, better than)	Linearity error (of measure- ment range, better than)	Max. length of fibre optic cable (when monitoring individual compounds) <sup>(4)</sup>	Hardware requirement
AR 600/AR	620 Analyser							
NO <sup>(2)</sup>	0-2000 mg/m <sup>3</sup>	0–150 mg/m <sup>3</sup>	1 mg/m <sup>3</sup>	±2 mg/m <sup>3</sup>	±2%	±1%	10 m	AR 600/620
NO <sub>2</sub>	0–2000 mg/m <sup>3</sup>	0–20 mg/m <sup>3</sup>	1 mg/m <sup>3</sup>	±2 mg/m <sup>3</sup>	±2%	±1%	200 m	AR 600/620
SO <sub>2</sub>	0–5000 mg/m <sup>3</sup>	0-80 mg/m <sup>3</sup>	1 mg/m <sup>3</sup>	±2 mg/m <sup>3</sup>	±2%	±1%	100 m	AR 600/620
NH3 <sup>(3)</sup>	0–1000 mg/m <sup>3</sup>	0–10 mg/m <sup>3</sup>	0.5 mg/m <sup>3</sup>	±1 mg/m <sup>3</sup>	±2%	±1%	10 m	AR 600/620
H <sub>2</sub> O	0–100% Vol.	0–30% Vol.	0.5% Vol.	±1% Vol.	±2%	±1%	100 m	AR 620
CO <sub>2</sub>	0–100% Vol.	_	0.5% Vol.	±1% Vol.	±2%	±1%	50 m	AR 620
AR 650 Ana	lyser							
NH₃	0–1000 mg/m <sup>3</sup>	_	2 mg/m <sup>3</sup>	±4 mg/m <sup>3</sup>	±2%	±1%	200 m	AR 650
HF	0–1000 mg/m <sup>3</sup>	—	0.5 mg/m <sup>3</sup>	±1 mg/m <sup>3</sup>	±2%	±1%	200 m	AR 650

 $^{\left( 1\right) }$  This data refers to a light path of one metre. For longer paths the maximum range is proportionally smaller. Products are available to create shorter paths in very wide stacks.

<sup>(2)</sup> Maximum SO<sub>2</sub> concentration 5 g/m<sup>3</sup>×metres. <sup>(3)</sup> Maximum SO<sub>2</sub> concentration 500 mg/m<sup>3</sup>×metres.

<sup>(4)</sup> When monitoring several compounds, the shortest fibre optic cable given by the set of components (refer to product sheet P9) has to be used.
<sup>(6)</sup> For AR 650 the same values are valid as maximum zero drift per year.

• Recommended monitoring path length: 1 to 5 metres.

· After wet scrubbers or when particulate concentration averaged over one metre is higher than 5 g/m<sup>3</sup>, the monitoring path length may have to be reduced.

Please contact your Opsis supplier to discuss your particular system requirements, including the compounds you wish to monitor. Separate product and other industrial application sheets are available. Specifications subject to change without notice

### **Continuous** Emissions Monitoring and Process Control

## Why Opsis?

High-performance, cross-stack monitoring Multi-gas and multi-path system Combines the benefits of both UV and IR No sample required High-quality instruments for operation in harsh environment Operates with a minimum of maintenance Easily calibrated Internationally approved Hundreds of systems installed worldwide Serviced by highly skilled service network



Opsis AB, Box 244 SE-244 02 Furulund Sweden Telephone Int +46 46 72 25 00 Telefax Int +46 46 72 25 01 E-mail info@opsis.se URL http://www.opsis.se

1996 06

A7